



PATENT

Case Docket No. KANEKO.014AUS

Date: October 11, 2010

Page 1

In re application of: Minoru Umemoto et al.

App. No. : 10/585,707

Filed : July 10, 2006

For : PROCESS OF FORMING ULTRAFINE
CRYSTAL LAYER, MACHINE COMPONENT HAVING
ULTRAFINE CRYSTAL LAYER FORMED BY THE
ULTRAFINE CRYSTAL LAYER FORMING PROCESS...

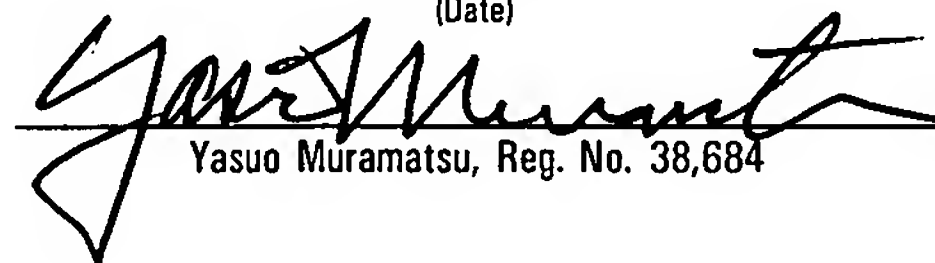
Examiner : Christopher S. Kessler

Art Unit : 1793

I hereby certify that this correspondence and all marked attachments
are being deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on

October 11, 2010

(Date)


Yasuo Muramatsu, Reg. No. 38,684

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Sir:

Transmitted herewith is a response to the office action for the above-identified utility application.

() An extension of time to respond for * month(s) is hereby requested.

Time Extension Fee:

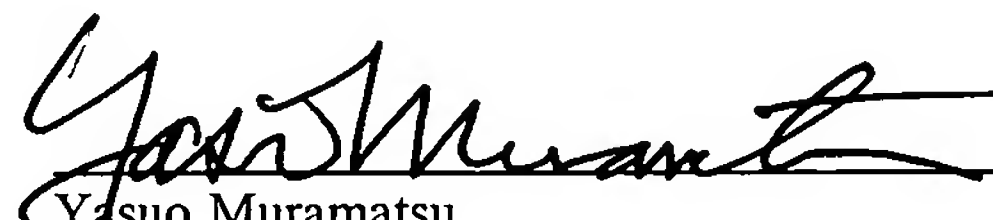
- () one month (\$130 large entity)
- () two months (\$490 large entity)
- () three months (\$1110 large entity)

Enclosed are:

(X) Amendment in twelve (12) pages.

(X) Copy of an article "A microstructural investigation of the surface of a drilled hole in carbon steel", J.G. Li, M. Umemoto, Y Todaka, K. Tsuchiya, Acta Materialia, 2006.

(X) Return prepaid postcard.


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